

<b>FORM PTO-1449 (MODIFIED)</b>  <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>  (Use several sheets if necessary)	<b>ATTY DOCKET NO.</b>  64,600-116	<b>SERIAL NO.</b>  To Be Assigned
	<b>APPLICANT</b> Sway Chuang	
	<b>FILING DATE</b> Filed Herewith	<b>GROUP</b> Unknown

**REFERENCE DESIGNATION      U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NO.	DATE	COUNTRY	CLAS S	SUB CLASS	TRANSLATION YES/NO
	AI						
	AJ						

**OTHER ART (including Author, Title, Date, pertinent pages, etc.)**

<i>BS</i>	AK	Bernard et al, "Thin Film Shape-Memory Alloy Actuated Micropumps", J. Microelectromechanical Systems, Vo. 7(2), June 1998, pp. 245-51
<i>BS</i>	AL	Jeong et al, "Fabrication and Test of a Thermopneumatic Micropump with a Corrugated p+ Diaphragm", Sensors and Actuators 83 (2000), pp. 240-55
<i>BS</i>	AM	Gong et al, "Design, Optimization and Simulation on Microelectromagnetic Pump", Sensors and Actuators, 83 (2000), pp. 200-07
<i>BS</i>	AN	Yang et al, "Design Fabrication and Testing of Micromachined Silicon Rubber Membrane Valves", J. Microelectromechanical Systems, Vol. 8(4), December 1999, pp. 393,402

**EXAMINER**

**DATE CONSIDERED**

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.